

On Page 1, after the Description please insert the following:

CROSS-REFERENCE TO RELATED APPLICATIONS

This application claims priority based on International Patent Application No. PCT/FR2004/050173, entitled "Method for Production of a Semiconductor Device with Auto-Aligned Metallisations" by Pierre-Jean Ribeyron and Marc Pirot. This application also claims the priority of the French application filed on April 29, 2003 under number 03 50136, which is incorporated by reference.